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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: OZAKI, Takashi, et al.

Group Art Unit: 2813

Serial No.: 10/517,765

Examiner: MCCALL SHEPARD, Sony

Filed: February 3, 2006

P.T.O. Confirmation No.: 6791

For.

SUBSTRATE TREATING APPARATUS AND METHOD FOR MANUFACTURING SEMICONDUCTOR DEVICE

PETITION FOR EXTENSION OF TIME

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Date: May 22, 2009

Sir:

Applicants petition the Commissioner for Patents to extend the time for response to the Office Action dated December 1, 2008 for three months, from March 1, 2009 to June 1, 2009.

Applicants filed a Petition for Two-Month Extension of Time and paid the fee on April 27, 2009. Accordingly, the Commissioner is authorized to charge our Deposit Account in the amount of \$620.00 to cover the remaining cost of the extension for a large entity. In the event that any additional fees are due in connection with this paper, pleases the extension of FC:1254 629.00 DA 2340.

Respectfully submitted,

KRATZ, OUINTOS & HANSON, LLP

William G. Kratz, Jr. Attorney for Applicant Reg. No. 22,631

WGK/ak

Atty. Docket No. **040509** Suite 400 1420 K Street, N.W. Washington, D.C. 20005 (202) 659-2930 85/26/2009 PSQUANA 90000004 10517765

PATER TRADE MARK OFFICE